Notice of References Cited Application/Control No. 10/640,858 Applicant(s)/Patent Under Reexamination PEDERSON, JOHN C. Examiner Jacob Y. Choi Art Unit Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,490,049	02-1996	Montalan et al.	362/240
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